34. (Amended) An apparatus for producing semiconductor devices comprising a moltensolder vessel arranged so that gold bump elements provided on the electrodes of a semiconductor element can be immersed in said vessel, and a support structure for hanging said semiconductor element, said support structure including a hanging mechanism comprising at least two mutually movably coupled coupling members so that the semiconductor element can float on the molten solder.

37. (Amended) An apparatus for producing semiconductor devices comprising a moltensolder vessel arranged so that gold bump elements provided on the electrodes of a semiconductor
element can be immersed in said vessel, and a support structure for holding said semiconductor
element, said support structure including a holding mechanism comprising at least two mutually
movably coupled coupling members so that the semiconductor element can float on the molten
solder and a pump-type adsorption head having an open suction hole for holding the semiconductor
element.